

Research and Development Section Indian Institute of Technology Guwahati Guwahati-781039, Assam

Applications are invited for Walk-in-interview of the following post(s) for Contractual recruitment in the project entitled, "Indian Nanoelectronics Users' Programme - Idea to Innovation (INUP-i2i)" at Centre for Nanotechnology, IIT Guwahati.

Date: 13th September 2023 (Wednesday)

Time: 10:00 A.M

Venue: Conference Room, Centre for Nanotechnology, IIT Guwahati

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|------------|---|--------------------------------|----------|-------------|-------------------------------|--------------------------|--|---|--|--|--|
| Sl. No. | C. Cr | Numbe r of Vacanc ies | Recomme | | Medical Require d (Rs.) | Total Amount (Rs.) | Duratio n of Appoin tment in month s | Qualifications | | | |
| 1 | SRF (DIRECT) | 10 | 35000.00 | Yes 6300.00 | 1250.00 | 42550.00 | 06 | Post Graduate in basic science or Graduate/Post Graduate in Professional Course selected through a process described through any one of the following: 1. Scholars selected through National Eligibility Test-CSIR-UGC NET including Lectureship (Assistant Professors hip) and GATE. 2. The selection process through National Level Examinations conducted by Central Government Departments and their Agencies and institutions such as DST, DBT, DAE, DOs, DRDO, MHRD, ICAR,ICMR, IISC, IISCR etc.+2yrs of Research Exp. Preferable requirements: Expertise in NanoScience, Nanotechnology, Nanobiology, Nanobiology, Nanoelectronics and hands-on-experience in Nanofabrication and characterization (such as AFM, SEM, TEM, XRD, Electro-Spinning Device, Materials Printing System, Laser Micromachining, Wire Bonding, Double Sided Mask Aligner, | | | |

| | | | | | | | | Thermal/E-Beam Evaporation, RF Magnetron Sputtering Unit, Oxidation/Diffusion Furnaces, Reactive Ion Etching, FESEM- EBL, Mask Writer, Raman, IR. |
|---|-----------------------------------|----|-------|----------------|---------|----------|----|---|
| 2 | Assistant Project Engineer | 01 | 28500 | Yes 5130.00 | 1250.00 | 34880.00 | 06 | Bachelor's degree in Engineering Preferable Experience: Training, Operation and Maintenance of ODF and Wire Bonder. They will also maintain the Web page for the online applications. |
| 3 | Associate Project Scientist | 01 | 35000 | Yes 6300.00 | 1250.00 | 42250.00 | 06 | Master's degree in Science or Bachelor's degree in Science + 4 yrs exp. Preferable Experience: Operation and Maintenance of Raman, UV-Vis Spectra, Fuel Cell Testing Facility. |
| 4 | Administra tive Assistant | 01 | 23500 | Yes 4230.00 | 1250.00 | 28980.00 | 06 | Master's degree in Commerce or Business Management Preferable Experience: To tackle the purchase related activities and to enable inventory management, accommodation, and travel for users. |

How to apply and selection process: Candidates have to appear in the walk-in-interview at 10:00 AM on 13th September 2023 (Wednesday). They have to send advance copy of their CV mentioning all educational qualifications, experience etc. to nano_off@iitg.ac.in within 10.09.2023 (5PM).

Selection will be based on the performance of the candidate in the interview. Candidates will not be sent any call letter separately.

For any clarification, contact: Nano Office, Centre for Nanotechnology, IIT Guwahati

Email: nano_off@iitg.ac.in

Phone: 3075

No campus accommodation will be available for the selected candidates. No TA/DA will be paid to the candidates for appearing in the test and interview.

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Assistant Registrar (R&D)